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Application No. <u>091170,625</u>	Prepared by <u>NH</u>	Tracking Number <u>05903139</u>	
Examiner-GAU <u>Fournson-2823</u>	Date <u>3-3-4</u>	Week Date <u>02/09/04</u>	
	No. of queries <u>1</u>	<u>IFW</u>	

JACKET

a. Serial No.	f. Foreign Priority	k. Print Claim(s)	p. PTO-1449
b. Applicant(s)	g. Disclaimer	l. Print Fig.	q. PTOL-85b
c. Continuing Data	h. Microfiche Appendix	m. Searched Column	r. Abstract
d. PCT	i. Title	n. PTO-270/328	s. Sheets/Figs
e. Domestic Priority	j. Claims Allowed	o. PTO-892	t. Other

SPECIFICATION

- a. Page Missing
- b. Text Continuity
- c. Holes through Data
- d. Other Missing Text
- e. Illegible Text
- f. Duplicate Text
- g. Brief Description
- h. Sequence Listing
- i. Appendix
- j. Amendments
- k. Other

CLAIMS

- a. Claim(s) Missing
- b. Improper Dependency
- c. Duplicate Numbers
- d. Incorrect Numbering
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- f. Punctuation
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MESSAGE

PTO-1449: Please either initial or line through citations. Copy provided for reference.

Franklyn

initials NH

RESPONSE

initials

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO.: 8733.6836		SERIAL NO.: 09/170,625	
LIST OF REFERENCES CITED BY APPLICANT (Use Several Sheets if Necessary)				APPLICANT: Duck Hyun CHOI			
				FILING DATE: October 13, 1998		GROUP: 2823	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA	4,309,225	01/1982	FAN et al.	148	1.5	
	AB	4,626,448	12/1986	HAYS	427	39	
	AC	5,364,664	11/1994	TSUBOUCHI et al.	427	535	
	AD	5,492,843	02/1996	ADACHI et al.	437	21	
	AE	5,576,222	11/1996	ARAI et al.	437	4	
	AF	5,619,044	04/1997	MAKITA et al.	257	64	
	AG	5,639,698	06/1997	YAMAZAKI et al.	437	228	
	AH	5,663,077	09/1997	ADACHI et al.	438	151	
	AI	5,677,240	10/1997	MURIKAMI et al.	437	195	
	AJ	5,985,741	11/1999	YAMAZAKI et al.	438	486	
	AK	6,066,547	05/2000	MAEKAWA	438	486	
	AL						
	AM						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
	AN	21-40915	05/1990	JP (Japan)	Abstract		
	AO	80-06053	01/1996	JP (Japan)	Abstract		
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)							
	AP	Y. Kawazu, et al., "Low-Temperature Crystallization of Hydrogenated Amorphous Silicon Induced by Nickel Silicide Formation", Japanese Journal of Applied Phys., Vol. 29, No. 12, December 1990, pp. 2698-2704					
	AQ						
	AR						
	AS						
EXAMINER:					DATE CONSIDERED:		

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*EXAMINER: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Duck-Kyon CHOI

Group Art Unit: 2823

Serial No.: 09/170,625

Examiner: S. Hawranek

Filed: October 13, 1998

For: METHOD FOR FABRICATING A THIN FILM TRANSISTOR



RELATED CASES STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicant hereby provides a list of pending U.S. applications or issued patents which may be related to the present application.

<u>Examiner's Initial</u>	<u>U.S. Serial Number</u>	<u>Filing Date</u>	<u>Inventor Name</u>	<u>Our Ref.</u>
_____	09/115,498	04/14/98	JANG et al.	8733.6584
_____	09/299,571	04/27/99	JANG et al.	8733.8205
_____	09/350,816	04/09/99	JANG et al.	8733.20020

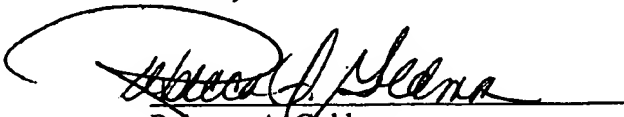
Date Considered: _____

Respectfully submitted,

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October 5, 2000

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